

L Number	Hits	Search Text	DB	Time stamp
1	5	"5179863"	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 19:45
2	20	(gap with (mask and wafer)) and error near signal	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 19:49
3	16	"4838693"	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 19:56
4	9	gap with (mask and wafer) and actuator near9 adjust\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 20:07
5	22	gap with (mask and wafer) and (refractive near index) near5 light	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 20:08
6	38	(measur\$3 or monitor\$3) near15 ((gap and distance) with ((pattern\$2 (mask or template)) and (wafer or substrate)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 20:13
7	38	(measur\$3 or monitor\$3) near15 ((gap and distance) with ((pattern\$2 (mask or template)) and (wafer or substrate)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 20:13
8	37	(measur\$3 or monitor\$3) near15 ((gap and distance) with ((mask or template) and (wafer or substrate)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 20:13
9	4	(measur\$3 or monitor\$3) near15 ((gap and distance) with (template and (wafer or substrate)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 20:14
10	4	(measur\$3 or monitor\$3) near15 ((gap and distance) with ((template) and (wafer or substrate)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 20:14
11	37	(plurality near1 (wavelengths or wavelength)) and ((measur\$3 or monitor\$3) with (mask and (substrate or wafer)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 20:14

L Number	Hits	Search Text	DB	Time stamp
1	6	((measur\$3 or monitor\$3) near15 ((gap and distance) with ((pattern\$2 near (mask or template)) and (wafer or substrate))))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 18:09
2	37	((measur\$3 or monitor\$3) near15 ((gap and distance) with ((mask or template) and (wafer or substrate))))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 18:12
3	4	((measur\$3 or monitor\$3) near15 ((gap and distance) with (template and (wafer or substrate))))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 18:10
4	4	((measur\$3 or monitor\$3) near15 ((gap and distance) with ((template) and (wafer or substrate))))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 18:16
5	0	"5179863" and wavelengths	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 18:17
6	0	"5179863" and wavelength	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 18:17
7	37	(plurality near1 (wavelengths or wavelength)) and ((measur\$3 or monitor\$3) with (mask and (substrate or wafer)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/04/14 18:18